L	Hits	Search Text	DB	-Time stamp
Number		·	•	_
8	824	turbidity and semiconductor	USPAT;	2003/10/20
			US-PGPUB;	08:19
			EPO; JPO;	
		·	DERWENT;	
			IBM TDB	
9	733	(turbidity and semiconductor) and (fluid	USPAT;	2003/10/20
		or liquid or gas)	US-PGPUB;	08:19
			EPO; JPO;	
			DERWENT;	
			IBM TDB	
5	21	turbidity and 451/\$.ccls.	USPĀT;	2003/10/20
			US-PGPUB;	08:20
			EPO; JPO;	
			DERWENT;	
			IBM TDB	
6	38	turbidity and 438/\$.ccls.	USPAT;	2003/10/20
			US-PGPUB;	08:28
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
7	21	turbidity and 216/\$.ccls.	USPAT;	2003/10/20
			US-PGPUB;	08:31
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
10	216	(turbidity and semiconductor) and	USPAT;	2003/10/20
		turbidity same (fluid or liquid or gas)	US-PGPUB;	08:32
			EPO; JPO;	
			DERWENT;	
			IBM TDB	

